

**Supporting information for:**

**Au nanoparticles-decorated porous gallium nitride as ultrasensitive substrates for surface enhanced Raman spectroscopy**

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The scanning electron microscope (SEM) images were acquired on a Hitachi S4800 SEM and the surface roughness of samples was achieved by AFM-Dimension 3100. All SEM images were taken at 0 tilt angle and 4.2 mm working distance, with 20 kV accelerating voltage. The X-ray diffraction (XRD) patterns were obtained by D8 Advance of Bruker AXS. Raman spectra were obtained on a LabRam HR 800 confocal Raman microscopy with 532.8 nm laser. UV-vis spectra were obtained on a LAMBDA 750 UV/Vis/NIR Spectro-photometer(PerkinElmer).

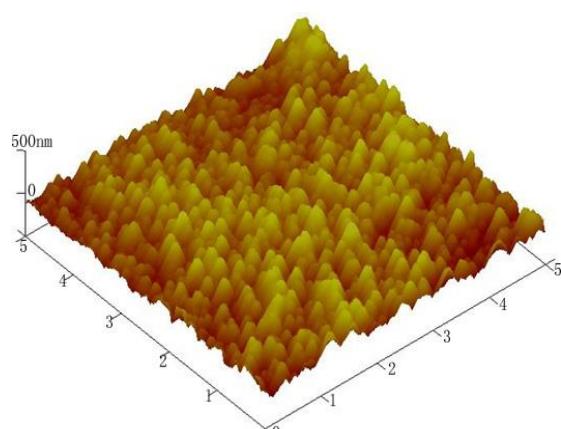
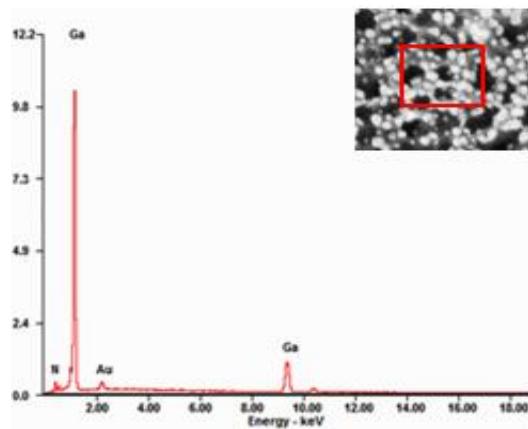
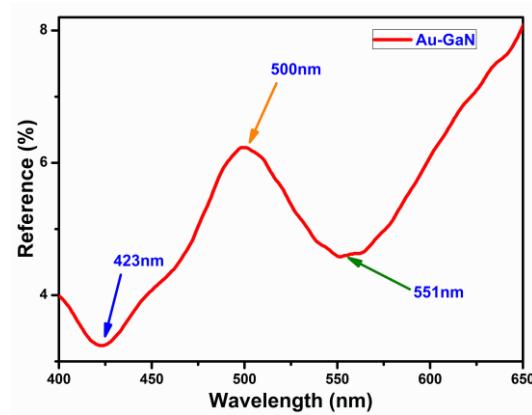


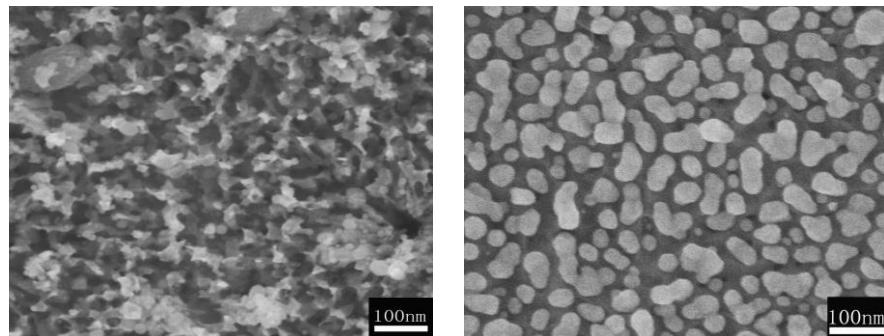
Fig. S1. AFM image of PGaN prepared by PEC etching in 0.5 molL<sup>-1</sup> H<sub>2</sub>SO<sub>4</sub>. The applied voltage was 6 V, and the etching time was 15 min.



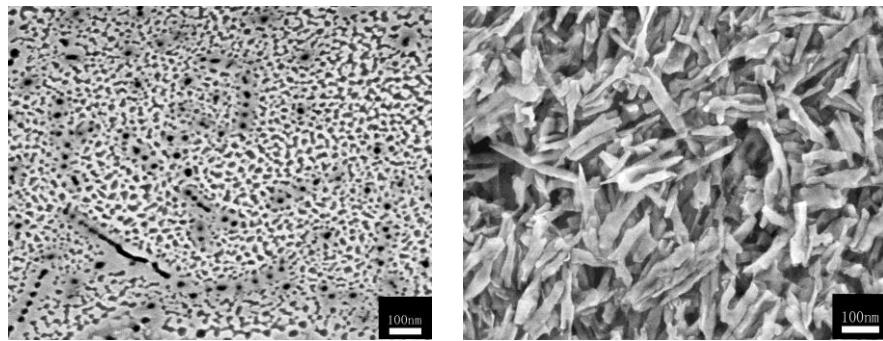
**Fig. S2.** EDX spectrum of Au/PGaN substrate.



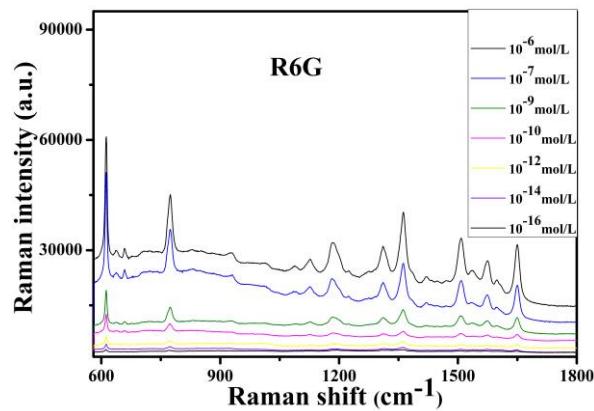
**Fig. S3.** Specular reflectance spectrum of Au/PGaN substrate.



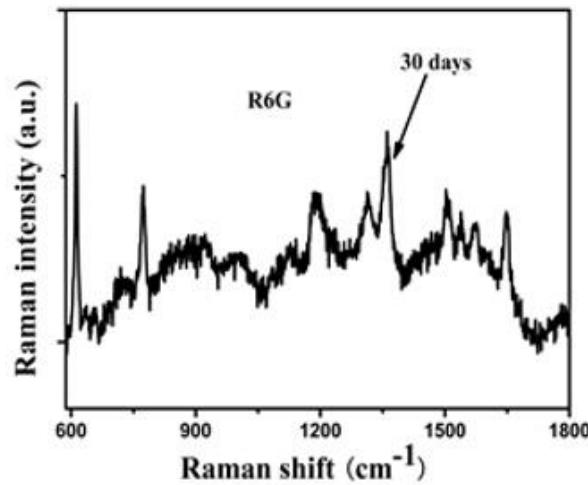
**Fig. S4.** SEM images of Au/PGaN substrates prepared with different cycles: (a) 2 and (b) 10 cycles.



**Fig. S5.** SEM images of PGaN substrate prepared by PEC etching with different etching time: (a) 7 and (b) 25 min.



**Fig. S6.** Raman spectrum of different R6G concentration:  $10^{-6}$ ,  $10^{-7}$ ,  $10^{-9}$ ,  $10^{-10}$ ,  $10^{-12}$ ,  $10^{-14}$  and  $10^{-16}$   $\text{mol L}^{-1}$ .



**Fig. S7.** Raman spectrum of  $10^{-16}$   $\text{mol L}^{-1}$  R6G recorded after 30 days storage in air.